

Application/Control No.	Applicant(s)/Patent under Reexamination
10/511,137	OGAWA, YUUICHIROU
Examiner	Art Unit
Justin R. Fischer	1733

	SEARCHED				
	JLAN		<del></del>		
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED				
Class	Subclass	Date.	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		DATE	EXMR	
B60C17/00, 04, 06		5/4/2007	JRF	
152/516, 517		5/4/2007	JRF	
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